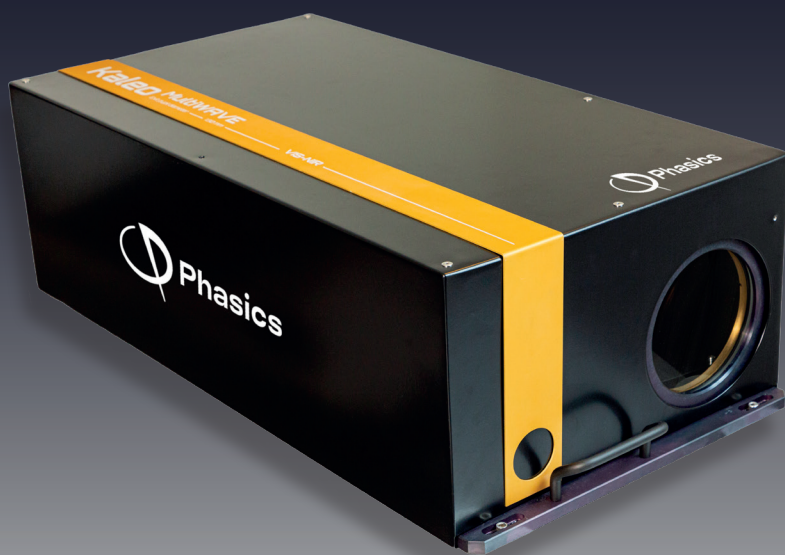


Kaleo MultiWAVE

multi-wavelength,
large dynamic range
interferometer





INTERFEROMETRIC SOLUTION FOR FILTERS AND COATED OPTICS TESTING AT DEDICATED WAVELENGTHS

PHASICS is innovating in optical metrology with a new instrument able to measure both transmitted and reflected wavefront error (TWE/ RWE). Coated and uncoated optics can be qualified over a diameter of 5.1 inches (130 mm) at their working wavelengths.

Kaleo MultiWAVE is an advantageous alternative and cost-effective solution to the purchase of several interferometers. The system offers a **measurement accuracy comparable to Fizeau interferometry**.

Kaleo MultiWAVE works at different wavelengths to perform qualification of optics and coatings at their working wavelengths.

KEY FEATURES



Up to 8 wavelengths



High dynamic range



WFE & MTF measurement

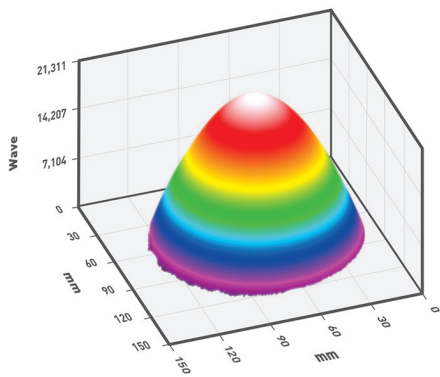


Insensitive to vibration



Compatible with MetroPro & ISO

PHASICS - The phase control company



HIGH DYNAMIC RANGE

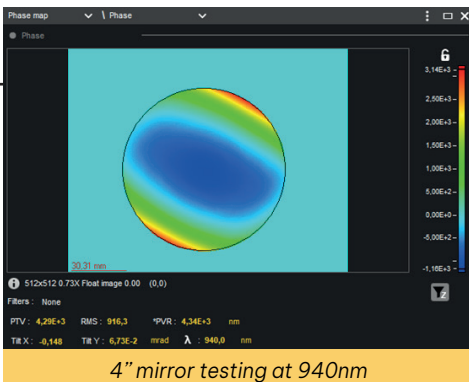
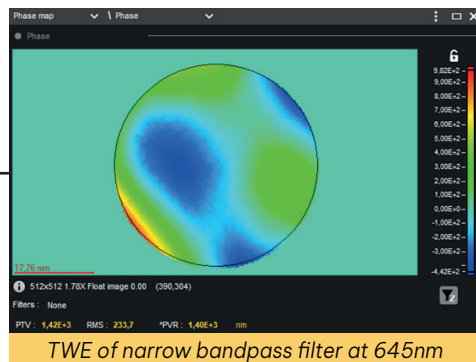
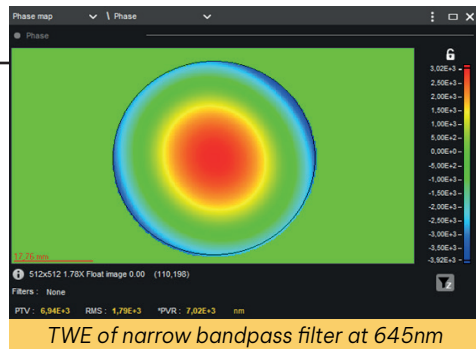
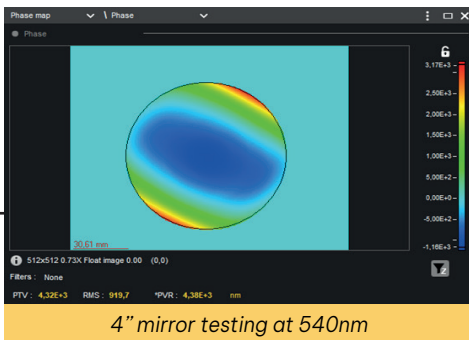
MEASUREMENT OF LARGE ABERRATIONS

- More than 20 of aberration can be measured with Kaleo MultiWAVE
- More dynamic range than a classical Fizeau interferometer

RWE of 5" wide band pass filter at 653nm

APPLICATIONS

- Coated optics and filters testing at real operating wavelengths
- High dynamics surface testing



ACHROMATIC SYSTEM

1

Same results at any wavelength

2

The instrument can be used at any wavelength to match the sample's operating wavelength

SYSTEM

Configuration	Double pass
Measurement capability	RWE of reflective surfaces TWE of transparent optics
Number of wavelengths per instrument	1 or 2 (standard), up to 8 (custom)
Custom wavelengths	Any wavelength from 193 nm to 14 μ m including: UV: 266, 355, 405 nm VIS/NIR: 550, 625, 780, 940, 1050 nm SWIR/MWR/LWIR: 1.55, 2.0, 3.39, 10.6 μ m
Clear aperture	5.1" (130 mm)
Beam height	108 mm
Alignment system	Live phase & Zernike coefficients display
Polarization	Compatible with depolarizing optics
Alignment FOV	+/- 2°
Pupil focus range	+/- 2.5 m
Dimension/Weight	910x600x260 mm ³ , 25kg
Vibration isolation	Not necessary

PERFORMANCES⁽¹⁾

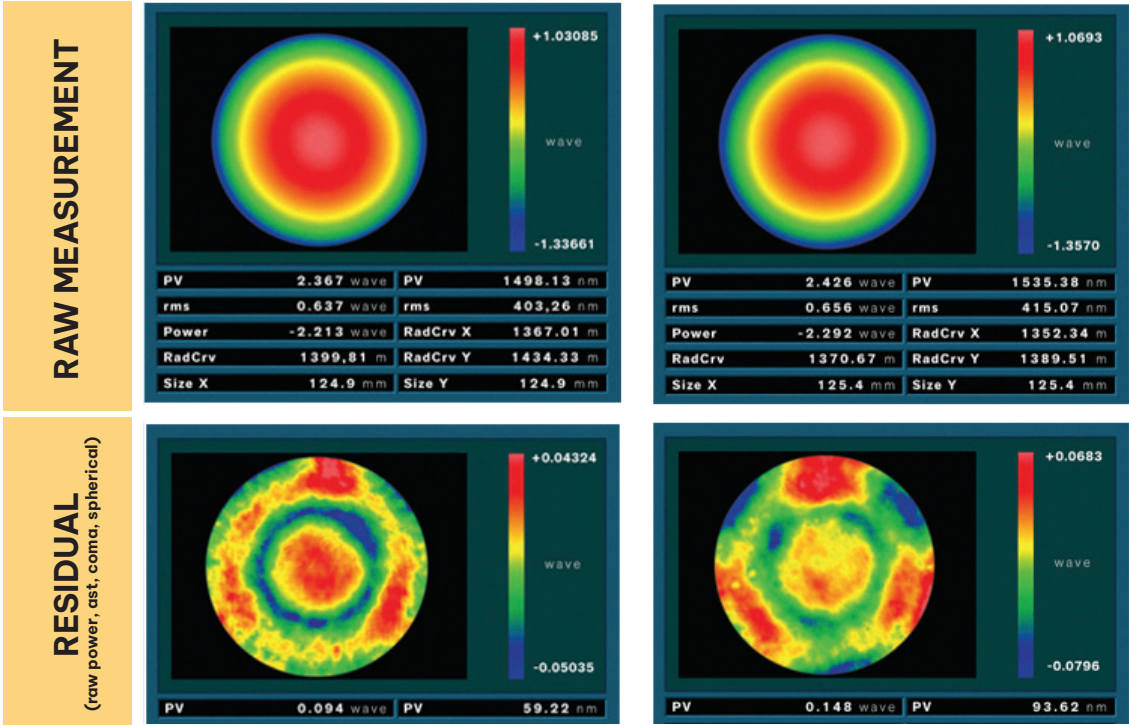
RMS repeatability ⁽²⁾	<0.7 nm (< λ /900)
Accuracy ⁽³⁾	80 nm PV
Dynamic range (defocus)	500 fringes (SFE=150 μ m)
Sample reflectivity range	~4% - 100%

(1) On a 4" pupil size, with a 625 nm source.

(2) 36 sequential measurements are performed on a 4" reference mirror, each being averaged 16 times. A reference is defined as the average of all odd numbered measurements. RMS repeatability is then defined as the average RMS difference plus 2 times the standard deviation of the difference between even numbered measurements and the reference.

(3) For a 1 μ m PV defocus.

RESULTS SIMILAR TO FIZEAU INTERFEROMETRY





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